

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tatsuo ITO et al.

Application No.: New U.S. National Stage of PCT/JP03/00557

Filed: July 26, 2004

Docket No.: 120503

For: METHOD FOR MANUFACTURING SEMICONDUCTOR WAFER, METHOD FOR
RECEIVING ORDER FOR MANUFACTURE OF SEMICONDUCTOR WAFER,
AND SYSTEM FOR RECEIVING ORDER FOR MANUFACTURE OF
SEMICONDUCTOR WAFER

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Claims as reflected in the listing of claims;**Remarks.**